

**SYSTEM AND METHOD FOR DESIGNING A CIRCUIT WHEREIN A SINGLE
TIMING ANALYSIS ENSURES ADEQUATE PERFORMANCE
IN MULTIPLE APPLICATIONS**

5 **TECHNICAL FIELD**

This invention relates generally to electronic circuits and, more particularly, to systems and methods for designing electronic circuits.

BACKGROUND OF THE INVENTION

10 An integrated circuit (IC) consists of electronic devices electrically connected by conductive wires called interconnect lines, or simply interconnects. The interconnects are typically patterned from conductive layers formed on or above the surface of a silicon substrate. Complex ICs include several layers or levels of interconnects spaced from one another by interlevel dielectric structures.

15 Integrated circuit designers typically work with building blocks including multiple components such as logic gates. In a similar manner, it is now possible for IC designers to take highly complex functional units or blocks, such as microprocessors, bus/network interfaces, and signal processors, and integrate them into an IC much like other less complex building blocks. Such functional units, commonly referred to as “cores,” are 20 becoming increasingly available.

25 System-on-a-chip (SOC) technology takes the core concept one step further, including all necessary circuits (e.g., cores) for a complete system, such as a cell phone or a digital camera, on a single IC. For example, an SOC for a sound-detecting device might include an audio receiver, an analog-to-digital converter, a microprocessor, memory, and input/output logic -- all on a single IC.

30 Most complex logic circuits are synchronous systems wherein operations of multiple subcircuits or functional units are orchestrated by one or more clock signals. Such clock signals impose timing constraints on the functional units. To help ensure a manufactured IC will perform one or more functions within timing constraints established by clock signals, timing analysis or verification is performed on the functional units individually and/or collectively during the design phase.

As a result of shrinking dimensions due to technology scaling, propagation delays

of logic devices continue to decline. At the same time, however, signal propagation times of interconnects (i.e., interconnect delays) have not been reduced to the same degree as reduced dimensions lead to increased resistance and larger resistance-capacitance (RC) parasitic delays. As a result, interconnect delays have become a larger fraction of signal 5 path delays. For technologies with minimum dimensions smaller than about 0.25 microns, interconnect delays become a major performance limiter for high frequency applications. Further, interconnects are also becoming the dominant factor in determining IC power dissipation.

FIGURES 1A-1B will now be used to illustrate a problem that arises when a 10 circuit is designed using values of environment factors (e.g., process speed, power supply voltage, temperature, and the like) adequate to meet the performance requirements of a first application, and the values of the environment factors are subsequently changed to meet the performance requirements of a new application. FIGURE 1A is a diagram of a first circuit path 100 including only devices (e.g., transistors) 102 between a pair of cycle 15 boundary latches 104A and 104B, where a signal launched by the latch 104A is captured by the latch 104B one cycle of a clock signal later. FIGURE 1B is a diagram of a second circuit path 106 including two interconnect lines (i.e., interconnects) 108A and 108B and a buffer 110 between another pair of cycle boundary latches 112A and 112B, where a signal launched by the latch 112A is captured by the latch 112B during the next cycle of 20 the clock signal. The buffer 110 is included in FIG. 1B only to reflect the need to maintain signal integrity along the circuit path 106.

Environment factors influencing propagation times of signals traveling along the circuit paths 100 and 106 include process speed, power supply voltage, and temperature. For example, when process speed and/or power supply voltage is increased or decreased, 25 the signal propagation time along the circuit path 100 expectedly decreases or increases, respectively, according to a process technology used to manufacture the devices 102. On the other hand, the signal propagation times (i.e., delay times) of the interconnects 108A-108B of FIGURE 1B remain substantially constant, and largely determine the delay time of the path 106. As a result, the delay time along the path 106 remains substantially 30 constant.

When a circuit including the paths 100 and 106 is designed using values of environment factors adequate to meet the performance requirements of a first application, and the values of the environment factors are subsequently changed to meet the

performance requirements of a new application, the above mentioned problem arises. For example, when process speed and/or power supply voltage is increased, the signal propagation time of the circuit path 100 of FIGURE 1A is expectedly reduced, allowing higher speed operation of the circuit. However, the substantially unchanged signal 5 propagation time of the circuit path 106 of FIGURE 1B may prevent higher speed operation of the circuit.

It would thus be advantageous to have a system and method for designing a circuit including multiple conductors wherein timing analysis performed at an operating point associated with a first application would also ensure adequate performance in a known or 10 projected second application.

SUMMARY OF THE INVENTION

A disclosed method for designing a circuit having multiple conductors includes selecting a first operating point corresponding to a first circuit application and a second 15 operating point corresponding to a second circuit application. A performance difference between circuit operation at the first and second circuit operating points is determined and used to compute a factor. The factor is applied to resistance values of the conductors, thereby producing modified conductor resistance values. A timing analysis of the circuit is performed using the modified conductor resistance values. A computer program 20 product is described including computer program code for carrying out some or all of the operations of the method.

A disclosed apparatus for designing the circuit includes means for applying the factor to the resistance values of the conductors and for performing the timing analysis of the circuit. A timing analysis system is described including a memory system and a 25 central processing unit (CPU) coupled to the memory system. The memory system includes software including instructions for applying the factor to resistance values of the conductors, and a timing analysis tool including instructions for performing the timing analysis of the circuit. The CPU is configurable to fetch instructions from the memory and to execute the instructions.

BRIEF DESCRIPTION OF THE DRAWINGS

The invention may be understood by reference to the following description taken in conjunction with the accompanying drawings, in which like reference numerals identify similar elements, and in which:

5 FIGURE 1A is a diagram of a first circuit path including only devices (e.g., transistors) between a pair of cycle boundary latches;

FIGURE 1B is a diagram of a second circuit path including two interconnect lines (i.e., interconnects) and a buffer between another pair of cycle boundary latches;

10 FIGURE 2 is a diagram of one embodiment of a system-on-a-chip (SOC) including multiple functional blocks, wherein each of the functional blocks includes devices connected by electrically conductive interconnects;

15 FIGURE 3 is a diagram of one embodiment of a 3-dimensional environment space in which the functional blocks of the SOC of FIGURE 2 operate, and wherein the environment space exists in a system with a process speed dimension, a power supply voltage dimension, and a circuit temperature dimension;

20 FIGURE 4 is a diagram of a temperature plane of the 3-dimensional environment space of FIGURE 3 resulting from selection of a circuit operating temperature of the functional blocks of FIGURE 2, wherein an environment window exists in the temperature plane, and wherein a first operating point of one of the functional units is located at or near a center of the environment window, and wherein a second operating point of the functional unit is located in the environment window above and to the right of the first operating point;

FIGURE 5 is a diagram of the temperature plane of FIGURE 4 wherein the second operating point has been moved below and to the left of the first operating point;

25 FIGURE 6 is a flow chart of one embodiment of a method for designing a circuit including multiple conductors, wherein the method includes several operations; and

FIGURE 7 is a diagram of a timing analysis system for carrying out some or all of the operations of the method of FIGURE 6.

30 **DETAILED DESCRIPTION**

In the following discussion, numerous specific details are set forth to provide a thorough understanding of the present invention. However, those skilled in the art will

appreciate that the present invention may be practiced without such specific details. In other instances, well-known elements have been illustrated in schematic or block diagram form in order not to obscure the present invention in unnecessary detail. Additionally, for the most part, details concerning network communications, electro-magnetic signaling techniques, and the like, have been omitted inasmuch as such details are not considered necessary to obtain a complete understanding of the present invention, and are considered to be within the understanding of persons of ordinary skill in the relevant art.

It is further noted that, unless indicated otherwise, all functions described herein may be performed in either hardware or software, or some combination thereof. In a preferred embodiment, however, the functions are performed by a processor, such as a computer or an electronic data processor, in accordance with code, such as computer program code, software, and/or integrated circuits that are coded to perform such functions, unless indicated otherwise.

FIGURE 2 is a diagram of one embodiment of a system-on-a-chip (SOC) 200 including multiple functional blocks 202A-202C. Each of the functional blocks 202A-202C is a relatively complex circuit that performs one or more functions. As indicated in FIG. 2, the functional blocks 202A-202C are interconnected and communicate with one another to accomplish a desired function of the SOC 200.

In general, each of the functional blocks 202A-202C includes devices connected by electrically conductive wires called traces or interconnects. Exemplary interconnects of the functional block 202A are labeled 204 in FIG. 2.

FIGURE 3 is a diagram of one embodiment of a 3-dimensional environment space 300 in which the functional blocks 202A-202C of the SOC 200 of FIGURE 2 operate. In the embodiment of FIG. 3, the environment space 300 exists in a system with a process speed dimension, a power supply voltage dimension, and a circuit temperature dimension.

In a typical design process used to design the functional blocks 202A-202C of the SOC 200 of FIGURE 1, an operating temperature of the functional blocks 202A-202C is first selected. FIGURE 4 is a diagram of a temperature plane 400 of the 3-dimensional environment space 300 of FIGURE 3 resulting from selection of a circuit operating temperature of the functional blocks 202A-202C of FIGURE 2. In FIG. 4, an environment window 402 exists in the temperature plane 400 bounded by minimum and maximum process speeds and minimum and maximum power supply voltages.

A first operating point 404 is selected within the environment window 402 corresponding to the SOC 200 application of the functional blocks 202A-202C. In general, the first operating point 404 is selected dependent upon performance requirements of the SOC 200 application of the functional blocks 202A-202C (e.g., 5 speed, electrical power dissipation, and the like). In FIGURE 4, the operating point 404 is located at or near a center of the environment window 402, and considered a “nominal” operating point. In general, the operating point 404 may be located anywhere in the environment window 402.

There can also be other applications for one or more of the functional blocks 10 202A-202C of FIGURE 2 having different performance requirements. A second operating point 406 is shown in FIGURE 4 corresponding to a second application of the functional block 202A. The second application may be known at the same time as the first application, or may be a projected application. The second operating point 406 is, in general, selected dependent upon the performance requirements of the second application.

15 In FIGURE 4, the second operating point 406 exists in the environment window 402 in the temperature plane 400. It is noted that the second operating point 406 may exist in another environment window in a different temperature plane.

The two major digital logic circuit performance factors are speed (maximum 20 frequency of a synchronizing clock signal) and electrical power dissipation. Digital logic circuits may be manufactured using any one of several available process technologies. In a complementary metal oxide semiconductor (CMOS) digital logic circuit manufactured using a selected process technology, the speed and electrical power dissipation of the circuit are directly related -- higher circuit speed results in proportionally higher electrical power dissipation. Selecting a (more expensive) higher performance process technology 25 with smaller devices (i.e., devices with smaller physical dimensions) may allow the same CMOS circuit to operate faster and/or with reduced electrical power dissipation.

In general, within a selected process technology, both the speed and power 30 dissipation of a CMOS circuit are directly proportional to process speed and power supply voltage, and inversely proportional to temperature. In this example, it is assumed that the selected process technology stays the same. In FIGURE 4, the fact that a positive change in process speed “ ΔP ” and a positive change in power supply voltage “ ΔV ” exists between the first operating point 404 and the second operating point 406 indicates the

speed requirement of the second application is greater than the SOC 200 application, and the corresponding increased power dissipation is acceptable.

5 In FIGURE 4, a performance difference between operation at the second operating point 406 and the first operating point 404 is indicated by a vector 408 directed from the first operating point 404 to the second operating point 406.

A numerical performance difference factor may be estimated using relationships between performance and process speed, voltage and temperature, the changes in process speed, power supply voltage, and circuit temperature. The performance difference factor is generally a value "k" such that a performance at the second operating point 406 is k 10 times the performance at the first operating point 404. That is, the performance difference factor k is a ratio of the performance at the second operating point 406 to the performance at the first operating point 404.

For example, tests performed on CMOS circuits manufactured using a given process technology may indicate the following relationship between device propagation 15 times (i.e., delay times) and power supply voltage: $\text{delay1}/\text{delay2} = V_{DD2}/V_{DD1}$, where delay1 is the device delay time at power supply voltage V_{DD1} and delay2 is the device delay time at power supply voltage V_{DD2} . Such relationships may be used to determine the performance difference factor k.

20 The performance difference factor k may also be determined by simulating operation of the functional block 202A. For example, a technology model library may be used that specifies device speeds at various environmental conditions. A first performance level may be determined at the first operating point 404, and a second performance level may be determined at the second operating point 406. The first and second performance levels may be used to determine the value k.

25 In general, interconnects have signal propagation times (i.e., delay times) dependent on the electrical characteristics of the interconnects, including resistance and capacitance. If the interconnects 204 of the functional block 202A are designed to meet the lower performance requirements of the SOC 200 application, an upper limit on performance established by the substantially constant delay times of the interconnects 204 30 may prevent the functional block 202A from operating at the higher performance requirement of the second application.

In order to ensure that the signal propagation times of the interconnects 204 will not prevent the functional block 202A from operating at the higher performance

requirement of the second application, the resistance values of the interconnects 204 are modified. The performance difference between operation at the second operating point 406 and the first operating point 404 is used to compute a factor. (A factor greater than 1 is referred to as an “uplift” factor, and a factor less than 1 is called a “downshift” factor.)

- 5 The factor is applied to the resistance values of the interconnects 204 of the functional block 202A, thereby producing modified resistance values. The modified resistance values are used to perform a timing analysis of the functional block 202A at the first operating point 404.

In general, the performance difference factor k described above is used to
10 compute a second factor “ r ” to be applied to the resistance values of the interconnects 204 of the functional block 202A. For example, the factor r may be computed using $r = a(k)$, where “ a ” can, in general, be any value. The value a may be termed a “scaling value.” The value of a may, for example, be set to 1 such that $r = k$ and the resistance values of the interconnects 204 scale directly with the difference in performance between the
15 second operating point 406 and the first operating point 404.

For example, assume the performance difference factor k associated with the vector 408 in FIGURE 4 is determined to be 1.5, and $r = k$. The factor 1.5 may be applied to the resistance values of the interconnects 204 of the functional block 202A by, for example, multiplying the resistance values of the interconnects 204 of the functional
20 block 202A by the factor 1.5. The resulting increased resistance values are used to perform a timing analysis of the functional block 202A at the first operating point 404. If timing constraints are not met, the interconnects 204 of the functional block 202A may be modified to meet the timing constraints. In any case, using the increased resistance values advantageously ensures that the interconnects 204 of the functional block 202A are
25 not under-designed such that they establish an upper performance limit that prevents the functional block 202A from operating at the higher performance requirement of the second application without, for example, allowing a longer cycle time (i.e., period) of a clock signal to complete operations in the second application.

FIGURE 5 is a diagram of the temperature plane 400 of FIGURE 4 wherein the
30 second operating point 406 has been moved below and to the left of the first operating point 404. The vector 408 is again directed from the first operating point 404 to the second operating point 406, and indicates a performance difference between operation at the second operating point 406 and the first operating point 404.

In FIGURE 5, negative values of the change in process speed ΔP and the change in power supply voltage ΔV indicate the speed requirement of the second application is less than the SOC 200 application. The power dissipation is also expectedly reduced.

For example, assume the performance difference factor k associated with the 5 vector 408 in FIGURE 5 is determined to be 0.5, and $r = k$. The factor 0.5 may be applied to the resistance values of the interconnects 204 of the functional block 202A by, for example, multiplying the resistance values of the interconnects 204 of the functional block 202A by the factor 0.5. The resulting reduced resistance values are used to perform a timing analysis of the functional block 202A at the first operating point 404. If timing 10 constraints are not met, the interconnects 204 of the functional block 202A may be modified. In any case, using the decreased resistance values advantageously ensures that the interconnects 204 of the functional block 202A are not over-designed such that, for example, additional layers of interconnect are unnecessarily required in the second application.

15 FIGURE 6 is a flow chart of one embodiment of a method 600 for designing a circuit including multiple conductors (e.g., the functional block 202A of FIGURE 2). The method 600 may be used, for example, to design one or more of the functional blocks 202A-202C of the SOC 200 of FIG. 2. During a first operation 602 of the method 600, a first operating point (e.g., the first operating point 404 of FIGURE 4) is selected 20 corresponding to a first application (e.g., use of the functional block 202A in the SOC 200 of FIG. 2 as described above).

25 During an operation 604, a second operating point (e.g., the second operating point 406 of FIGURE 4) is selected corresponding to a second application (e.g., use of the functional block 202A in an application other than the SOC 200 of FIGURE 2). A performance difference (e.g., a performance difference factor associated with the vector 408 in FIGURES 4 and 5) is determined between circuit operation at the first and second operating points during an operation 606.

30 During an operation 608, the performance difference is used to compute a factor (e.g., the factor r described above). The factor is applied to resistance values of the conductors, thereby producing modified conductor resistance values, during an operation 610. For example, as described above, the factor r may be applied to the resistance values 35 of the conductors by multiplying the resistance values of the conductors by the factor r , thereby producing the modified conductor resistance values.

During an operation 612, a timing analysis of the circuit is performed using the modified conductor resistance values. The timing analysis is performed to ensure the circuit will operate correctly in the presence of one or more timing constraints. If the timing constraints are not met, the conductors may be modified. In any case, using the 5 modified resistance values advantageously ensures that the conductors are not over-designed or under-designed as described above. When a result of the timing analysis verifies the circuit will operate correctly in the presence of the one or more timing constraints, the circuit will also likely meet performance requirements of the second application.

10 It is noted that the method 600 may be applied to each of multiple circuits of a system-on-a-chip (SOC). For example, the method 600 may also be applied to the functional blocks 202B and 202C of the SOC 200 of FIGURE 2. The resulting factors r may be greater than 1 for some circuits and less than 1 for others.

15 FIGURE 7 is a diagram of a timing analysis system 700 for carrying out some or all of the operations of the method 600 of FIGURE 6 described above. In the embodiment of FIG. 7, the timing analysis system 700 includes a computer system 702 and a medium 704 having computer software 706 and/or a data file 708 stored thereon. The computer system 702 includes a central processing unit (CPU) 710 coupled to a memory system 712 and to a device 714, all of which are located in an enclosure 716. 20 The CPU 710 is also coupled to a keyboard 718, a mouse 720, and a monitor 722.

25 The software 706 includes computer program code for carrying out some or all of the operations of the method 600 of FIGURE 6. In one embodiment, the data file 708 includes the factor (e.g., the factor r) to be applied to resistance values of circuit conductors. Alternately, the data file 708 may include modified conductor resistance values for circuit conductors.

As indicated in FIGURE 7, the software 706 and/or the data file 708 may also reside in the memory system 712. For example, the device 714 may transfer the software 706 from the medium 704 to the memory system 712. The CPU 710 may execute the computer program code of the software 706, thereby producing the data file 708 in the 30 memory system 712. The device 714 may be used to transfer the data file 708 from the memory system 712 to the medium 704.

As indicated in FIGURE 7, a model 724, a timing analysis tool 726, and a process technology model library 728 also reside in the memory system 712. In general, the

model 724 includes one or more computer files describing the components of an electronic circuit and their interconnections. The model 724 may be, for example, a layout file including component placement information used to manufacture the electronic circuit. The timing analysis tool 726 is computer software including computer 5 program code for carrying out the timing analysis during operation 612 of the method 600 described above. The process technology model library 728 includes functional and/or electrical data regarding the electronic circuit components needed to perform the timing analysis.

When the timing analysis system 700 is used to carry out the operations 610 and 10 612 of the method 600, the CPU 710 executes the computer program code of the software 706 and the timing analysis tool 726. When the data file 708 includes the factor (e.g., the factor r) to be applied to resistance values of circuit conductors, the CPU 710 may access the process technology model library 728 under the control of the software 706 to obtain conductor resistance values (or data used to compute the conductor resistance values), 15 and apply the factor as described above to compute the modified conductor resistance value. Under the control of the software 706 and/or the timing analysis tool 726, the CPU 710 may perform the timing analysis using the modified conductor resistance values.

When the data file 708 includes the modified conductor resistance values for the circuit conductors, the CPU 710 may access the data file 708 under the control of the 20 software 706 to obtain the modified conductor resistance values, and perform the timing analysis using the modified conductor resistance values under the control of the software 706 and/or the timing analysis tool 726.

As described above, the timing analysis is performed to ensure the circuit will 25 operate correctly in the presence of one or more timing constraints. If the model 724 does not meet timing constraints during the timing analysis due to signal propagation times (i.e., delay times) of circuit conductors, a user of the timing analysis system 700 preferably uses the computer system 702 to modify various physical aspects of the circuit conductors of the model 724, as well as architectural and logical functions, until the timing constraints are met.

30 In any case, as described above, using the modified resistance values advantageously ensures that the circuit conductors are not over-designed or under-designed. When a result of the timing analysis verifies the circuit will operate correctly in

the presence of the timing constraints, the circuit will also likely meet performance requirements of the second application.

The particular embodiments disclosed above are illustrative only, as the invention may be modified and practiced in different but equivalent manners apparent to those skilled in the art having the benefit of the teachings herein. Furthermore, no limitations are intended to the details of construction or design herein shown, other than as described in the claims below. It is therefore evident that the particular embodiments disclosed above may be altered or modified and all such variations are considered within the scope and spirit of the invention. Accordingly, the protection sought herein is as set forth in the claims below.